

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**priority** Application Serial No. ....09/592,604  
Confirmation No. .... unknown  
**priority** Filing Date ..... June 12, 2000  
Inventor..... F. Gonzalez  
Assignee.....Micron Technology, Inc.  
**priority** Group Art Unit.....2818  
**priority** Examiner ..... T. P. Le  
Attorney's Docket No. ....MI22-2393  
Customer No. ....021567  
Title: Methods Of Forming Semiconductor Constructions

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS**

EV318283495